

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: KAJIHARA, et al.
Serial No.: 09/328,910
Filed: June 9, 1999
For: LEADFRAME SEMICONDUCTOR INTEGRATED
CIRCUIT DEVICE USING THE SAME, AND METHOD
OF AND PROCESS FOR FABRICATING THE TWO
Group: 2815
Examiner: J. Clark
Conf. No.: 7455

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 14, 2008

Sir:

The following statement of the substance of the personal interview conducted between the PTO personnel as listed on the Interview Summary and the undersigned on January 8, 2008 is being submitted in reply to the requirement in the Interview Summary dated January 15, 2008.

The statement of the substance of the interview in the Interview Summary is complete and correct.

To the extent necessary, applicants petition for an extension of time under 37 CFR 1.136. Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli,

Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case No.1374.32049R00),
and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

/Paul J. Skwierawski/
Paul J. Skwierawski
Registration No. 32,173

PJS/slk
703-312-6600